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## Contents

vii	Authors
ix	Conference Committee
SESSION 1	ADHESIVES AND MATERIALS
10371 02	Adhesive bonds for optics: analysis and trade-offs [10371-1]
10371 03	Advancements in adhesive mounting of optics [10371-2]
10371 04	ZERODUR - bending strength: review of achievements [10371-4]
SESSION 2	ELEMENTS
10371 05	2-µm optical time domain reflectometry measurements from novel Al-, Ge-, CaAlSidoped and standard single-mode fibers [10371-5]
SESSION 3	OPTOMECHANICAL ANALYSIS I
10371 06	LLIMAS: revolutionizing integrating modeling and analysis at MIT Lincoln Laboratory [10371-7]
10371 07	The compound diffraction grating in the Ivory optomechanical modeling tools [10371-8]
10371 08	Linear analysis using secants for materials with temperature dependent nonlinear elastic modulus and thermal expansion properties [10371-9]
SESSION 4	OPTOMECHANICAL SYSTEMS I
10371 09	System engineering of complex optical systems for mission assurance and affordability [10371-10]
10371 OB	HabEx primary mirror trade studies [10371-12]
SESSION 5	STABILITY AND ALIGNMENT
10371 0C	Design and test of precision vertical and horizontal linear nanopositioning flexure stages with centimeter-level travel range for x-ray instrumentation [10371-13]
10371 0D	Trajectory error analysis of a flexure pivot type quide for linear nanopositionina [10371-14]

10371 OE	The development of alignment turning system for precision len cells [10371-15]
10371 OF	Lithography lens mounting flexure number design and aberration analysis [10371-16]
10371 0G	Double Arm Linkage precision Linear motion (DALL) Carriage, a simplified, rugged, high performance linear motion stage for the moving mirror of an Fourier Transform Spectrometer or other system requiring precision linear motion [10371-17]
SESSION 6	OPTOMECHANICAL ANALYSIS II
10371 OH	Analysis technique for controlling system wavefront error with active/adaptive optics [10371-18]
10371 01	Using integrated models to minimize environmentally induced wavefront error in optomechanical design and analysis [10371-19]
10371 OJ	Using multi-disciplinary optimization and numerical simulation on the transiting exoplanet survey satellite [10371-20]
SESSION 7	MOUNTING
10371 OK	Adaptive optics mounting method for higher second harmonic generation efficiency of large aperture KDP crystal [10371-21]
10371 OM	Cryogenic, infrared, optical beamsplitter wavefront error analysis and test [10371-23]
SESSION 8	OPTOMECHANICAL SYSTEMS II
10371 ON	Optomechanical design of TMT NFIRAOS Subsystems at INO [10371-24]
10371 00	Recent advancements in robotic micro-optical assembly at the Lockheed Martin Optical Payload Center of Excellence [10371-25]
10371 OP	The opto-mechanical design process: from vision to reality [10371-26]
10371 OR	Comparison of lenses' thermal expansion formulation in Zemax versus ANSYS with SigFit post processing [10371-34]
	POSTER SESSION
10371 OS	Mirrors design, analysis and manufacturing of the 550mm Korsch telescope experimental model [10371-29]
10371 OT	Optimization of a 16 inches diameter primary mirror assembly of a ground-based telescope [10371-30]

10371 OU	Development of an athermalized optomechanical system of large aperture remote sensing instruments [10371-31]
10371 0V	Removal of diamond turning marks with magneto-rheological finishing [10371-32]
10371 0X	Large area of MCP electronic rinse system design [10371-6]